



IPW

PATENT APPLICATION
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q76032

Hidetsugu SHIMURA

Appln. No.: 10/627,996

Group Art Unit: 2852

Confirmation No.: 4275

Examiner: Hoah H. TRAN

Filed: July 28, 2003

For: APPARATUS AND METHOD OF FORMING PATCH IMAGE FOR OPTIMIZING
DENSITY CONTROL FACTOR

AMENDMENT UNDER 37 C.F.R. § 1.111

MAIL STOP AMENDMENT

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated September 30, 2004, please amend the above-
identified application as follows on the accompanying pages.

TABLE OF CONTENTS

AMENDMENTS TO THE CLAIMS	2
REMARKS	16